



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **TANAKA, Yasuaki**

Serial No.: **10/042,345**

Filed: **January 11, 2002**

B3
NEA
Group Art Unit: **1756**

Examiner: **NICOLE M. BARRECA**

P.T.O. Confirmation No.: **6310**

For. **PROJECTION APPARATUS, METHOD OF MANUFACTURING THE APPARATUS, METHOD OF EXPOSURE USING THE APPARATUS, AND METHOD OF MANUFACTURING CIRCUIT DEVICES BY USING THE APPARATUS**

SUPPLEMENTAL PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Date: August 30, 2002

Sir:

This is a Supplemental Preliminary Amendment for the above-captioned patent application.

Please consider the following remarks in support of the Preliminary Amendment filed on August 28, 2002:

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SEP 04 2002
TC 1700